



Attorney Docket No.: 989_001DIV 1 (now 1153_010 DIV1)

PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): James E. Moon, et al.

Serial No.: 10/004,463

Art Unit: 1763

Filed: November 02, 2001

Examiner: Olsen, Allan W.

Title: **METHOD FOR FABRICATING MEMS AND
MICROFLUDIC DEVICES USING LATENT MASKING TECHNIQUE**

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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**NOTICE OF LOSS OF
ENTITLEMENT TO SMALL ENTITY STATUS**

Sir:

Pursuant to 37 C.F.R. § 1.27(g)(2), Applicants hereby notify the U.S. Patent and Trademark Office that they no longer claim small entity status, and respectfully request that small entity status be removed with regard to the patent application identified above.

While no fee is believed due with this submission, the Commissioner is hereby authorized to charge any additional fees associated with this submission, or credit any overpayment, to Deposit Account No. 50-0289.

Dated: 8.19.03



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